IN RE APPLICATION OF: Akira HOKAZONO, et al.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

GAU:

SERIAL NO: NEW APPLICATION		EXAMINER:	
FILED:	HEREWITH		
FOR:	SEMICONDUCTOR DE	VICE AND METHOD OF MANUFACTURING THE SAME	
REQUEST FOR PRIORITY			
COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313			
	efit of the filing date of U.S to the provisions of 35 U.S	S. Application Serial Number 10/076,497, filed February 19, 20 S.C. §120.	02, is claimed
☐ Full benefit of the filing date(s) of §119(e):		U.S. Provisional Application(s) is claimed pursuant to the provisional No. Date Filed	sions of 35 U.S.C.
Applicants claim any right to priority from any earlier filed applications to which they may be entitled pursuant to the provisions of 35 U.S.C. §119, as noted below.			
In the matter of the above-identified application for patent, notice is hereby given that the applicants claim as priority:			
COUNTRY Japan		APPLICATION NUMBER 2001-386518 MONTH/DAY/YEA December 19, 2001	<u>R</u>
Certified copies of the corresponding Convention Application(s) □ are submitted herewith □ will be submitted prior to payment of the Final Fee ■ were filed in prior application Serial No. 10/076,497 filed February 19, 2002 □ were submitted to the International Bureau in PCT Application Number Receipt of the certified copies by the International Bureau in a timely manner under PCT Rule 17.1(a) has been acknowledged as evidenced by the attached PCT/IB/304. □ (A) Application Serial No.(s) were filed in prior application Serial No. filed ; and □ (B) Application Serial No.(s)			
☐ are submitted herewith			
☐ will be submitted prior to payment of the Final Fee			
		Respectfully Submitted, OBLON, SPIVAK, McCLELLA MAIER & NEUSTADT, P.C.	AND,
22850		Eckhard H. Kuesters Registration No. 28,870	Yorlepp
Tel. (703) 413-3 Fax. (703) 413-2 (OSMMN 05/03 I:\ATTY\EDG\2397	2220	Edwin D. Garlepp Registration No. 45,330	